



In re the Application of

Kazunori ANAZAWA

Application No.: 10/080,701

Filed: February 25, 2002

Docket No.: 112055

For: PRODUCING APPARATUS AND PRODUCING METHOD FOR MANUFACTURING  
CARBON STRUCTUREINFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

P.O. Box 1450

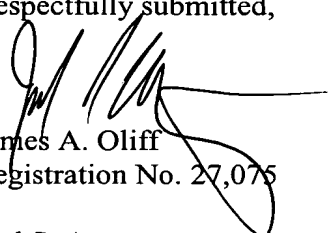
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references 2-4 and 6-8 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 3. English-language Abstracts of the non-English language references 2-6 are attached hereto.
- ☒ 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 2-3 and 5-6.
- ☒ 5. A concise explanation of the relevance of the non-English language references 2, 4, 6 appears in the Appendix attached hereto.

Respectfully submitted,

  
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JAO:JSA/smk

Date: December 30, 2003

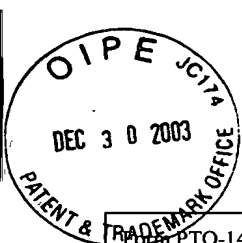
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Sheet 1 of 1

PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 112055		APPLICATION NO. 10/080,701	
				INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			
				APPLICANT Kazunori ANAZAWA			
				FILING DATE February 25, 2002			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1	5,482,601	1/9/1996	OHSIMA et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	2	JP A 08-48510 w/ Abst & Trans	2/20/1996	Japan			
	3	JP A 2002-69756 w/ Abst & Trans	3/8/2002	Japan			
	4	JP A 58-185767 w/ Abstract	10/29/1983	Japan			
	5	JP A 07-216660 w/ Abst & Trans	8/15/1995	Japan			
	6	JP A 2002-356316 w/ Abst & Trans	12/13/2002	Japan			
	7	EP 0 665 187 A1	8/2/1995	Europe			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	8	Kazunori ANAZAWA et al., "High-purity carbon nanotubes synthesis method by an arc discharging in magnetic field", Applied Physics Letters, July 22, 2002, Vol. 81. Num 4, Pgs. 739-741					
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: December 30, 2003